


## POWER OF ATTORNEY OR AUTHORIZATION OF AGENT

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|--|----------------------------------|-------------|--|--------------------------|------------------|
| <b>Title of Invention</b>  | Method of Managing Wafer Defects |             |  |                          |                  |
| First Named Applicant :  | Hung-En Tai                      |             |  |                          |                  |
| Attorney Docket Number :   | LKSP0051USA                      |             |  |                          |                  |
| <p>I hereby appoint the registered practitioner(s) at Customer Number:</p> <p>027765</p>  <p>as attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.</p> <p>I am the Applicant/Inventor.</p> <p>Full Name of Applicant of Record:</p> <table border="1"><tr><td colspan="2">Winston Hsu</td></tr><tr><td>Signature: /Winston Hsu/</td><td>Date: 2004-09-08</td></tr></table> |                                  | Winston Hsu |  | Signature: /Winston Hsu/ | Date: 2004-09-08 |
| Winston Hsu  |                                  |             |  |                          |                  |
| Signature: /Winston Hsu/   | Date: 2004-09-08                 |             |  |                          |                  |